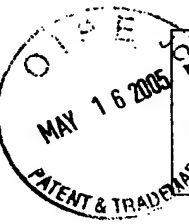


IFW



I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.
Dated: May 13, 2005 Signature: (Michael R. Hull)

Docket No.: 29926/39505
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Young-Soo Kim

Application No.: 10/615,038

Confirmation No.: 3909

Filed: July 8, 2003

Art Unit: 2891

For: ATOMIC LAYER DEPOSITION OF
TITANIUM NITRIDE USING BATCH TYPE
CHAMBER AND METHOD FOR
FABRICATING CAPACITOR BY USING THE
SAME

Examiner: Bradley Smith

RESPONSE TO RESTRICTION REQUIREMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

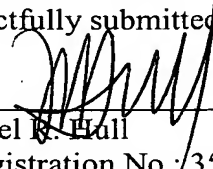
Dear Sir:

In response to the restriction requirement imposed in the office action mailed on April 13, 2005, applicant provisionally elects specie I (claims 1-2 and 7-8, *with traverse*). This application is already in prosecution and a first office action has been issued. All claims were examined in the first office action and only now, after a first examination, has a restriction been issued. In any event, applicant respectfully submits that claim 1 is allowable over all art of record and therefore an early indicating all claims being allowed and considered is respectfully requested.

The Commissioner is authorized to charge any fee deficiency required by this paper, or credit any overpayment, to Deposit Account No. 13-2855.

Dated: May 13, 2005

Respectfully submitted,

By  _____
Michael R. Hull

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